

Fig. 1

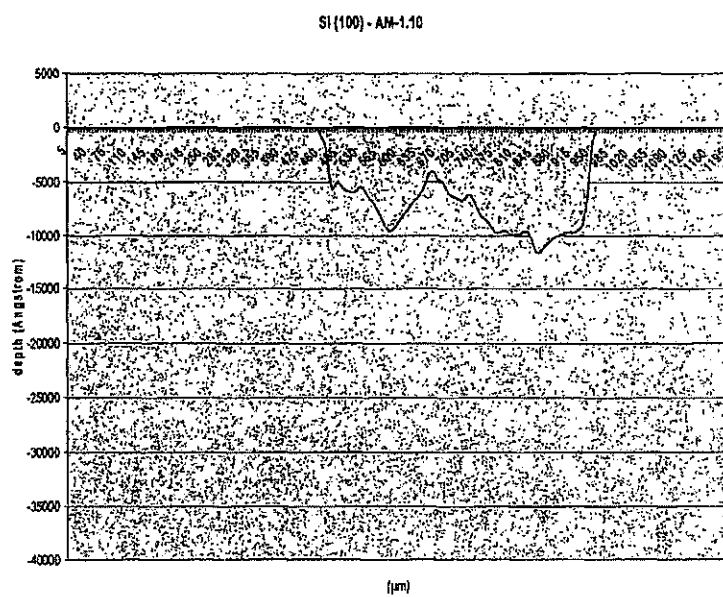


Fig. 2

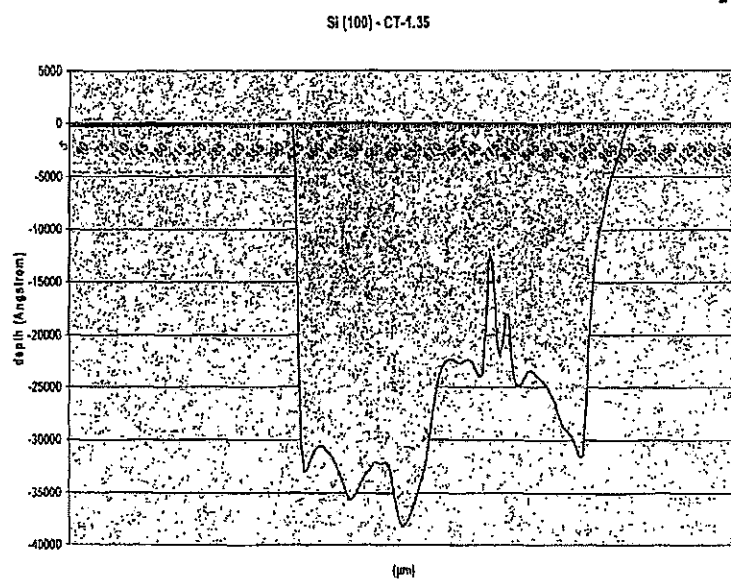


Fig. 3

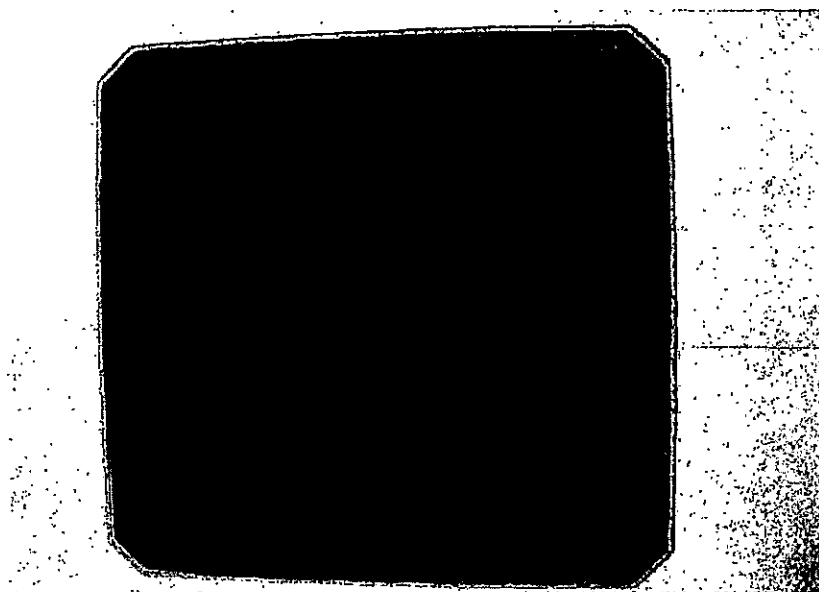


Fig. 4

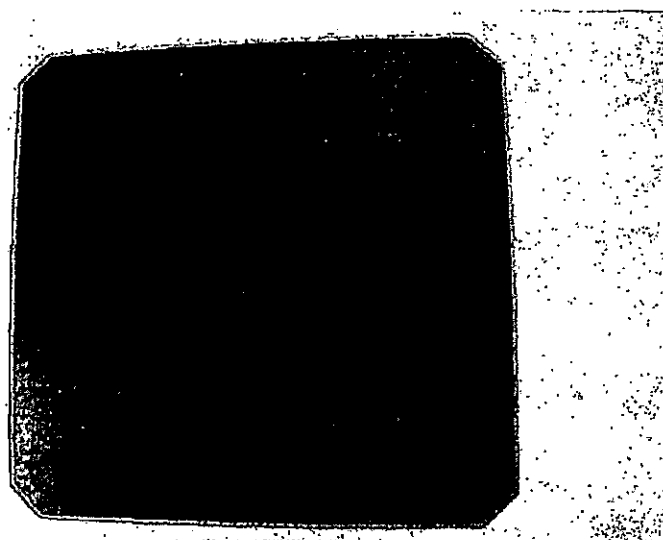


Fig. 5

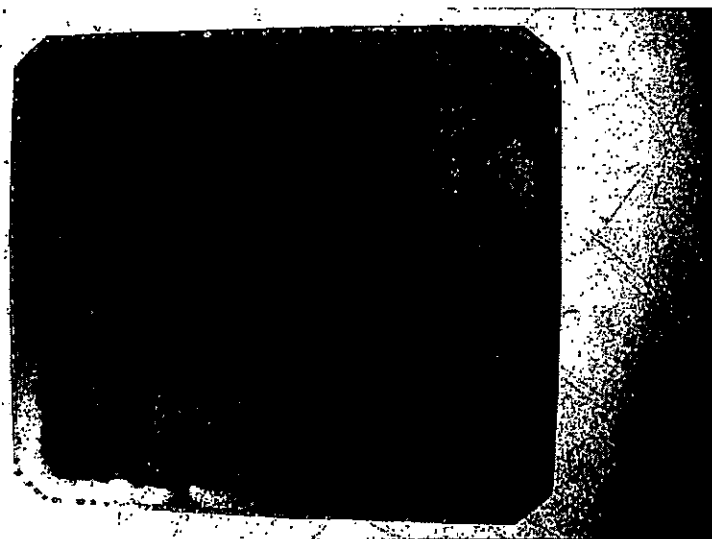


Fig. 6

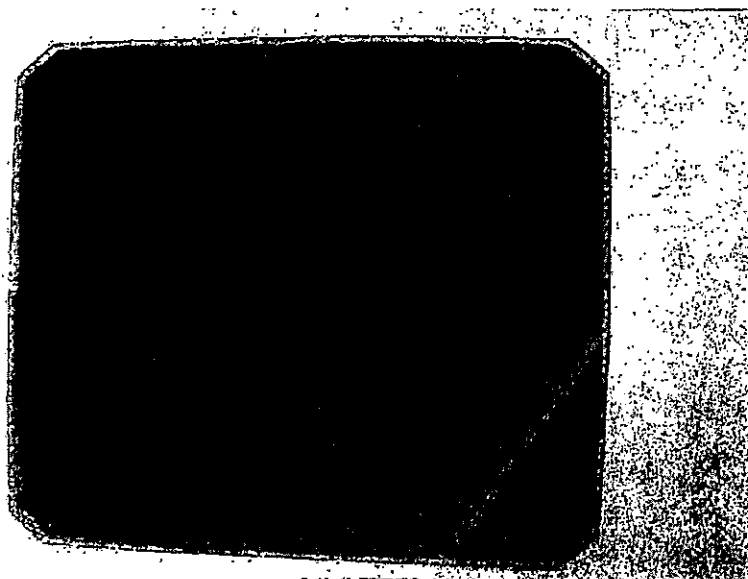


Fig. 7

Molten polymer sheath,
prevents paste liquefaction and paste spread after etching at room temperature on Si wafers

